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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

SEONG DEOK AHN, ET AL.

Application No.: 10/672,013

Filed: September 26, 2003

For: **METHOD AND APPARATUS USING  
LARGE-AREA ORGANIC VAPOR  
DEPOSITION FOR FORMATION OF  
ORGANIC THIN FILMS OR ORGANIC**

Art Group:

Examiner:

## STATUS INQUIRY

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

The above-captioned application, an amendment thereto, or an Appeal Brief was filed more than 18 months ago and no substantive Office Action has issued to date. Please provide the current status of the application and an indication of when the next Action is expected to issue.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR &amp; ZAFMAN LLP

Date: 4/26/05

Eric S. Hyman, Reg. No. 30,139

## CERTIFICATE OF MAILING/TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Nadya Gordon 4/26/05  
Nadya Gordon Date

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